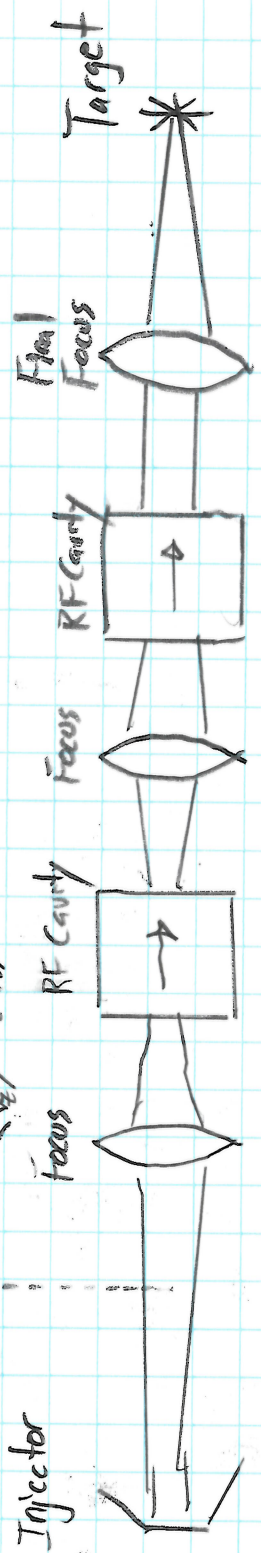
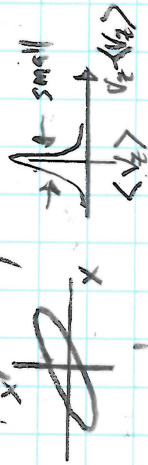


# Injectors

Ideally, want a distribution of monoenergetic particles with high current density and minimal phase-space volume.

- o Low phase-space volume  $\Rightarrow$  compact beam with strong focussability.



- o Injectors highly important: start with a bad beam, and likely impossible to "fix".

- Small spreads  $\Rightarrow$  compact, cheap, and robust accelerator

o Injectors often have intricate physics

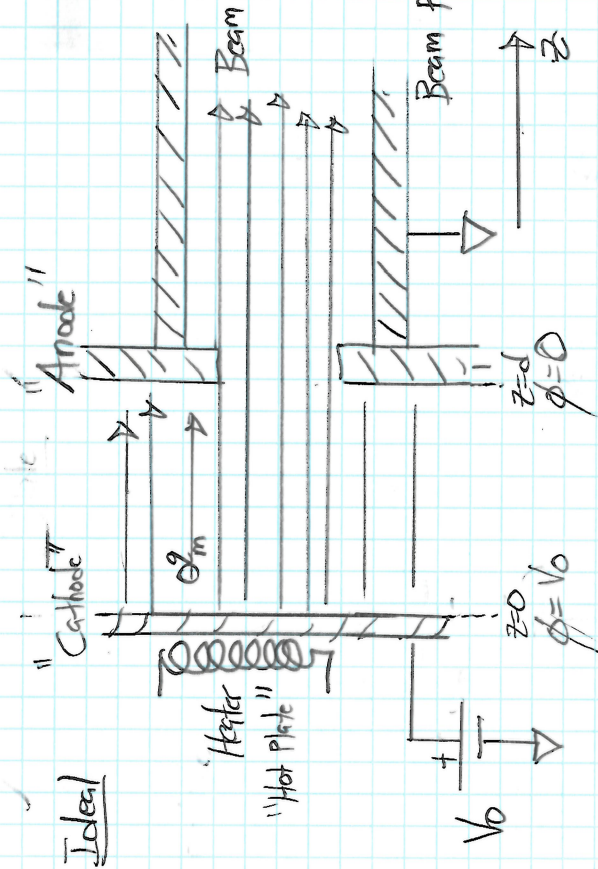
- Much potential gain with improvements
- Smaller systems, typically lower cost

} Ideal for student projects!

- o Not easy topic: but rich and high impact.

# Injector Geometry

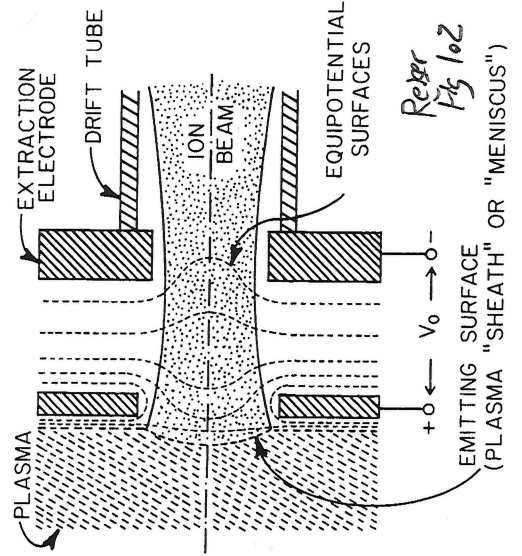
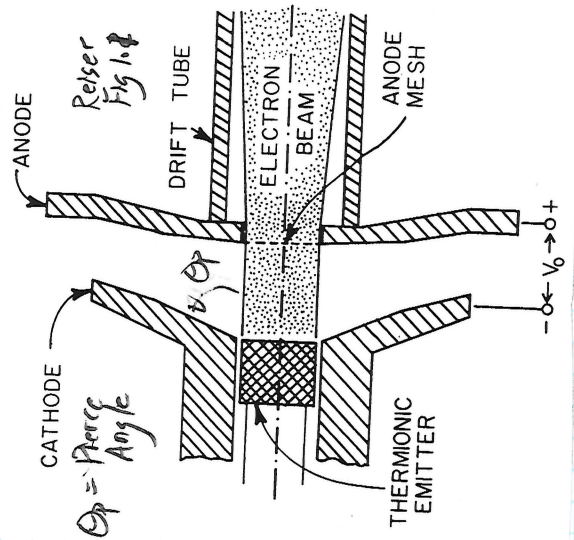
## Ideal Diode



Electrons

Accelerator  
Focusing  
Optics

- $V_0 =$  Source bias
- $q =$  particle charge
- $m =$  particle mass
- $R =$  Radius Aperture
- $d =$  Anode - Cathode Separation



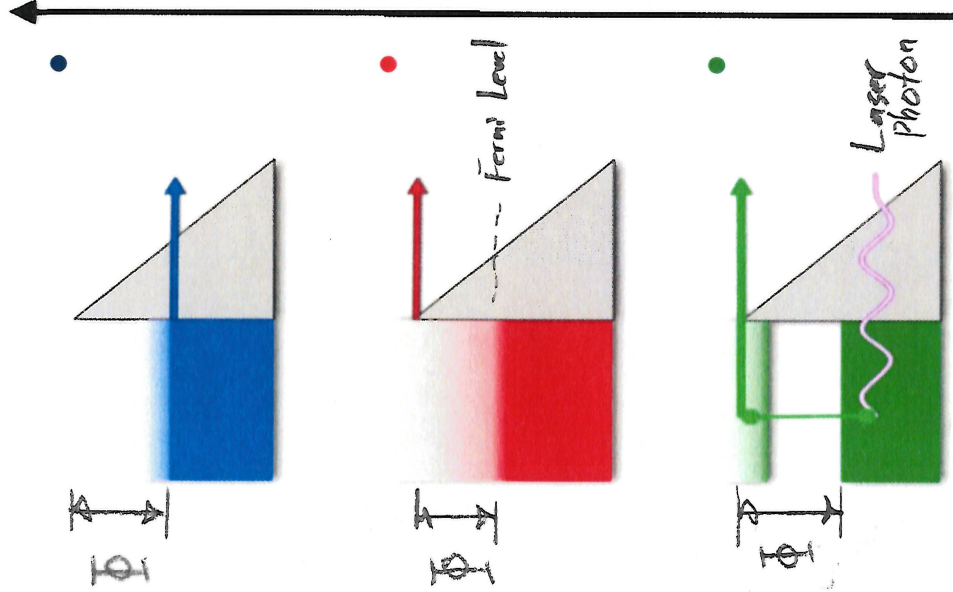
Ions

- Plasma
- ICR
- Discharge ...
- Hot Plate
- Doped Tungsten
- Al-Substrate

Reiser  
Fig 1.02

# The Canonical Emission Equations

(slide courtesy of Dr. K. Jensen, Naval Research Laboratory)



## Field Emission

Fowler Nordheim

E.L. Murphy, and R.H. Good,  
Physical Review 102, 1464 (1956).

$$J_{FN}(F) = A_{FN} F^2 \exp\left(-\frac{B\Phi^{3/2}}{F}\right)$$

$A_{FN} = \text{const}$ ,  $B = \text{const}$

$F = \text{Applied Field Measure} \propto E\text{-field}$

## Thermal Emission

Richardson-Laue-Dushman

C. Herring, and M. Nichols,  
Reviews of Modern Physics 21, 185  
(1949).

$$J_{RLD}(T) = A_{RLD} T^2 \exp\left(-\frac{\Phi}{k_B T}\right)$$

$T = \text{Source Temp (Absolute)}$

$A_{RLD} = \text{const}$

## Photoemission

Fowler-Dubridge

L.A. DuBridge  
Physical Review 43, 0727 (1933).

$$J_{MFD}(\lambda) = \frac{q}{\hbar\omega} (1-R) F_\lambda(\omega) \{\hbar\omega - \Phi\}^2 I_\lambda$$

$\hbar\omega = \text{photon Energy}$

Listed chronologically

Others - Factors associated

with Laser & Material/Barrier

# Thermal Electron Emission

Emitted from Maxwellian tail of Fermi-Dirac distribution of conduction electrons with current density

$$J = A T^2 e^{-W/k_B T}$$

$$A = \frac{4\pi m k_B^2}{h^3} = 1.02 \times 10^6 \frac{\text{Amp}}{\text{meter}^2 \text{K}^2}$$

Richardson-Dushman Eqn.  
Phil. Mag 28 633 (1914)  
Phys Rev. 21 623 (1923)

- $T$  = cathode temp. (absolute)
- $W$  = work function (few eV)
- $k_B$  = Boltzmann's const  $(\approx 10^{-5} \frac{\text{eV}}{\text{K}})$   
=  $8.6175 \times 10^{-5} \frac{\text{eV}}{\text{K}}$
- $m$  =  $e^-$  mass =  $9.11 \times 10^{-31} \text{ kg}$
- $e$  =  $e^-$  charge =  $1.6 \times 10^{-19} \text{ Coulomb}$
- $h$  = Planck's constant  
=  $6.63 \times 10^{-34} \text{ J}\cdot\text{sec}$

- In lab  $A$  often  $\sim 2 \times$  lower than formula.
- Thermionic cathode fabrication difficult,
  - Low  $W$
  - Long life at high temp.
  - Smooth surface

Tungsten common  
 $W = 4.5 \text{ eV}$   
 $T \sim 2500 \text{ K} \Rightarrow k_B T \sim 0.2 \text{ eV}$

$$J \sim 10^{-20} \frac{\text{Amp}}{\text{cm}^2}$$

## Photoemitters (not covered)

Often used for short pulse  $e^-$  sources for XFEL facilities and e-microscopes.

## Field Emitters

Used on electron microscopes etc for compact bright sources.

Very Diverse Topic.

Much in refs. USPAS courses on Photoemission & High Brightness Electron Injectors.

## Ion Emission

Generally more complex than electron sources.

Many different technologies for:

- Light Ions
  - Heavy Ions
  - Negative Ions ( $H^-$ )
- } Plasma often used  
or "Hot Plate" emitter.

Often plasma is confined by a magnetic field so ions can be born "magnetized"

- Generates phase-space correlations with more intricate beam dynamics downstream.

At NSCL / FRIB ECR = Electron Cyclotron Resonance ion sources used

- Produce a spectrum of high charge state ions that must be separated downstream.

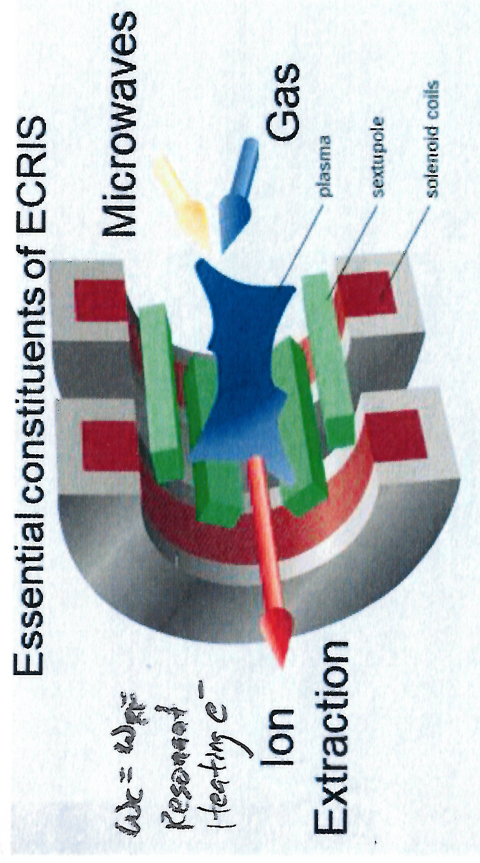
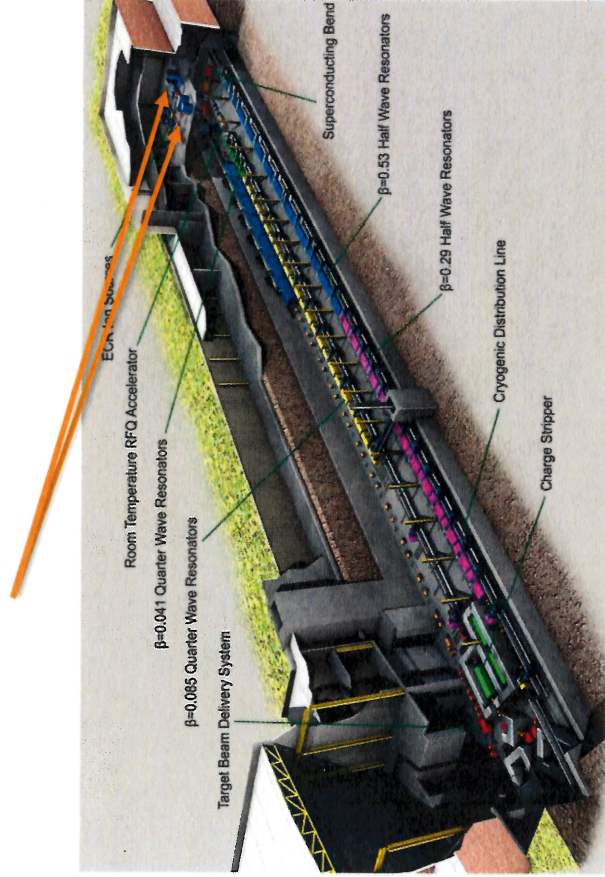
# Accelerator Facilities Use Electron Cyclotron Resonance Ion Source (ECRIS) to produce High Intensity, High Charge State Ion Beams

From B. Isherwood

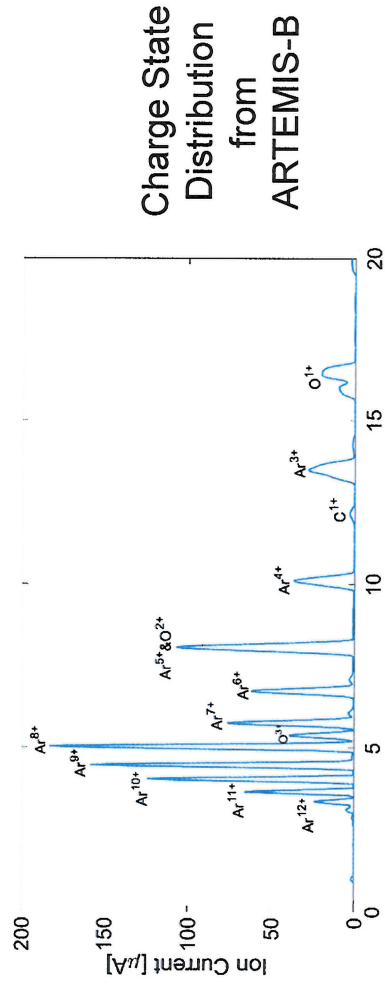
FRIB

Two ECRIS:

1. Room temperature 14 GHz ARTEMIS-B (Commissioning)
2. Superconducting 28 GHz VENUS based ECRIS (2020)

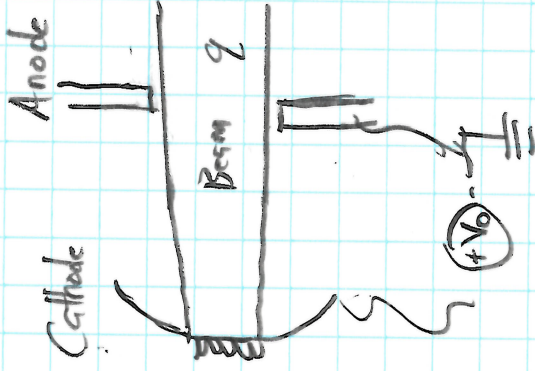


- Magnetic confinement and microwave heating are used to induce ionization
- GHz range microwaves ignite source plasma
- Solenoids and hexapole field confine the plasma



National Science Foundation  
Michigan State University  
NSF Grant 1632761

For both electrons and ions, cannot extract arbitrary current. Will ultimately be limited by charge already emitted pushing back.



o Particles accelerate in gap potential

o For fixed current density  $J$  at emission, charge density drops with distance from emitter

Poissons' Equation

$$\frac{d^2\phi}{dz^2} = -\frac{\rho}{\epsilon_0}$$

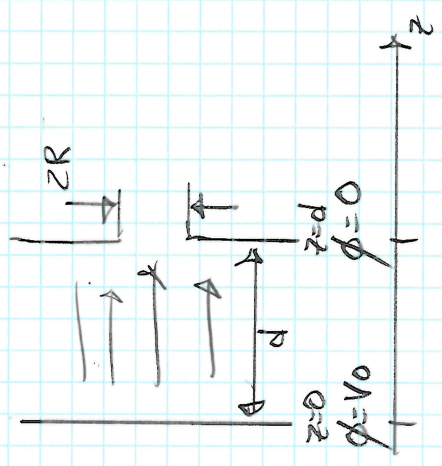
$$E_z = -\frac{d\phi}{dz}$$

$E_z$  will push back and suppress emission.

Limiting Current: "Child-Langmuir" value.

Analyze for steady flow;  $\frac{d\rho}{dt} = 0$ .

Model ions as a cold fluid:



$n(z,t)$  = Density  
 $V_z(z,t)$  = Flow Velocity

Charge Conservation

$$\frac{\partial \rho}{\partial t} + \nabla \cdot \vec{J} = 0$$

$$\Rightarrow \frac{\partial n}{\partial t} + \frac{\partial (n V_z)}{\partial z} = 0$$

$m$  = ion mass  
 $q$  = ion charge

$$\rho = qn$$

$$\vec{J} = qn \vec{V}_z$$

Continuity Equation

Momentum (Non-Rel. + Cold Fluid)

$$n \frac{d}{dt} (m \vec{V}_z) = qn \left[ \vec{E} + \vec{V} \times \vec{B} \right] - \nabla(P)$$

convective Der.  $\frac{d}{dt} = \frac{\partial}{\partial t} + V_z \frac{\partial}{\partial z}$

Field Coupling  $\vec{E} = \text{Elec. Field}$   
 $\vec{B} = \text{Mag. Field} = 0$

Cold Fluid  
 No Pressure

$$mn \frac{\partial V_z}{\partial t} + mn V_z \frac{\partial V_z}{\partial z} = qn E_z$$

Force Equation

Field (Electrostatic)

$$\nabla \cdot \vec{E} = \frac{\rho}{\epsilon_0}$$

$$\vec{E} = -\nabla \phi$$

Poisson Equation

$$\frac{\partial^2 \phi}{\partial z^2} = -\frac{qn}{\epsilon_0}$$



Analyze equations assuming steady flow.  $\frac{\partial}{\partial t} = 0$

1) Continuity Equation

$$\frac{\partial}{\partial z} n v_z + \frac{\partial}{\partial z} (n v_z) = 0$$

$$\boxed{2 n v_z = \text{const} \equiv J} \quad (1)$$

Notice this implies  $n \rightarrow \infty$  as  $v_z \rightarrow 0$  (near emitter). This is idealized but still expect very large  $n$  near emitter.

2) Force Equation

$$m \frac{\partial v_z}{\partial z} + m v_z \frac{\partial v_z}{\partial z} = q E_z = -q \frac{\partial \phi}{\partial z}$$

$$\frac{\partial}{\partial z} \left( \frac{1}{2} m v_z^2 \right) = -q \frac{\partial \phi}{\partial z} \Rightarrow \frac{1}{2} m v_z^2 = -q \phi + \text{const}$$

$v_z(0) = 0 \Rightarrow$  particles emitted near rest.

$$\frac{1}{2} m v_z^2 = q V_0 - q \phi$$

convenient ref choice

$$\phi(0) = V_0 \Rightarrow \boxed{\frac{1}{2} m v_z^2 = q \phi} \quad (2)$$

3) Poisson Equation

$$\frac{\partial^2 \phi}{\partial z^2} = \frac{2 q n}{\epsilon_0}$$

$$\boxed{\frac{\partial^2 \phi}{\partial z^2} = \frac{2 q n}{\epsilon_0} = \frac{2 q J}{\epsilon_0 (v_z/2)}} \quad (3)$$

Use (1)

$$\frac{\partial^2 \phi}{\partial z^2} = \frac{2 q J}{\epsilon_0 v_z} = \frac{2 q J}{\epsilon_0} \frac{2}{v_z}$$

$$\frac{\partial^2 \phi}{\partial z^2} = \frac{2 q J}{\epsilon_0} \frac{2}{v_z} \Rightarrow \frac{\partial^2 \phi}{\partial z^2} = \frac{2 q J}{\epsilon_0} \frac{2}{v_z}$$

$$\frac{\partial}{\partial z} \left[ \left( \frac{2 q J}{\epsilon_0} \right)^{1/2} z \right] = \left( \frac{2 q J}{\epsilon_0} \right)^{1/2} \Rightarrow \frac{2 q J}{\epsilon_0} z = \frac{1}{2} \left( \frac{2 q J}{\epsilon_0} \right)^{3/2} z^2$$

But  $\phi(z=0) = V_0 - \phi = 0$

$$\frac{\partial \phi}{\partial z}(z=0) = -\frac{\partial \phi}{\partial z} = 0 \Rightarrow E_z(0) = 0$$

$$\boxed{\frac{\partial \phi}{\partial z} = \frac{2 q J}{\epsilon_0} \left( \frac{z}{4 J} \right)^{1/2} = \frac{2 q J}{\epsilon_0} \left( \frac{z}{2 q J} \right)^{1/2}} \quad (4)$$

Space-Charge Limited Current as much charge drawn off as possible for  $E_z=0$  with a steady solution reached at stagnation

Integrate Poisson's Equation:

$$\frac{d\Phi}{dz} = \left(\frac{4J}{\epsilon_0}\right)^{1/4} \left(\frac{m}{2q}\right)^{1/4} dz$$

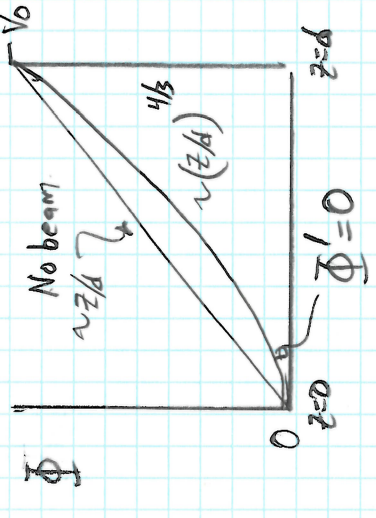
$$\frac{3}{4} \Phi \Big|_{z=0}^{z=d} = \left(\frac{4J}{\epsilon_0}\right)^{1/4} \left(\frac{m}{2q}\right)^{1/4} z \Big|_{z=0}^{z=d}$$

$$\Phi(z) = \left(\frac{3}{4}\right)^{4/3} \left(\frac{4J}{\epsilon_0}\right)^{1/3} \left(\frac{m}{2q}\right)^{1/3} z^{4/3}$$

Require:  
(constant)

$$\Phi(d) = V_0 \Rightarrow \Phi = V_0 \left(\frac{z}{d}\right)^{4/3}$$

$$\Rightarrow V_0 = \left(\frac{3}{4}\right)^{3/4} \left(\frac{4J}{\epsilon_0}\right)^{1/4} \left(\frac{m}{2q}\right)^{1/4} d^{4/3}$$



Solve for J:

$$\left(\frac{4J}{\epsilon_0}\right)^{1/4} = \left(\frac{4}{3}\right)^{3/4} \left(\frac{\epsilon_0}{m}\right)^{1/4} \left(\frac{2q}{m}\right)^{1/4} \frac{V_0}{d^{4/3}}$$

$$J = \frac{\epsilon_0}{4} \left(\frac{4}{3}\right)^{3/2} \left(\frac{2q}{m}\right)^{3/2} \frac{V_0^2}{d^2}$$

$$= \frac{4\epsilon_0}{9} \left(\frac{2q}{m}\right)^{3/2} \frac{V_0^2}{d^2}$$

Current Density  $J = \text{const} \frac{V_0^{3/2}}{d^2}$

const =  $\frac{4}{9} \epsilon_0 \left(\frac{2q}{m}\right)^{3/2}$

Child-Langmuir = Current Density

Also called "Child-Langmuir Law"

Current

$$I = \pi R^2 J = \frac{4\sqrt{2}\pi}{9} \epsilon_0 \left(\frac{2q}{m}\right)^{3/2} \left(\frac{R}{d}\right)^2 V_0^{3/2}$$

R = Radius  
Beam Aperture

$$= \left\{ \begin{array}{l} 0.232 \left(\frac{R}{d}\right)^2 (V_0 [\text{kV}])^{3/2} \text{ A} \\ \text{electrons (5/9n A/p)} \\ 5.043 \left(\frac{R}{d}\right)^{1/2} \left(\frac{R}{d}\right)^2 \left(\frac{V_0}{1 \text{ kV}}\right)^{3/2} \text{ mA} \\ \text{ions} \end{array} \right.$$

$$m = 1.67 \times 10^{-27} \text{ kg}$$

$$q = 1.6 \times 10^{-19} \text{ C}$$

Want for source:  $J = \text{const} \cdot V_0^{3/2} / d^2$

$J$  high  $\Rightarrow V_0$  large,  $d$  small

But most also suppress:

### 1) Voltage Breakdown

$$V_0 \approx 100 \text{ kV} \begin{cases} \left(\frac{d}{1 \text{ cm}}\right) & \text{for } d \lesssim 1 \text{ cm} \\ \left(\frac{d}{1 \text{ cm}}\right)^{1/2} & \text{for } d > 1 \text{ cm} \end{cases}$$

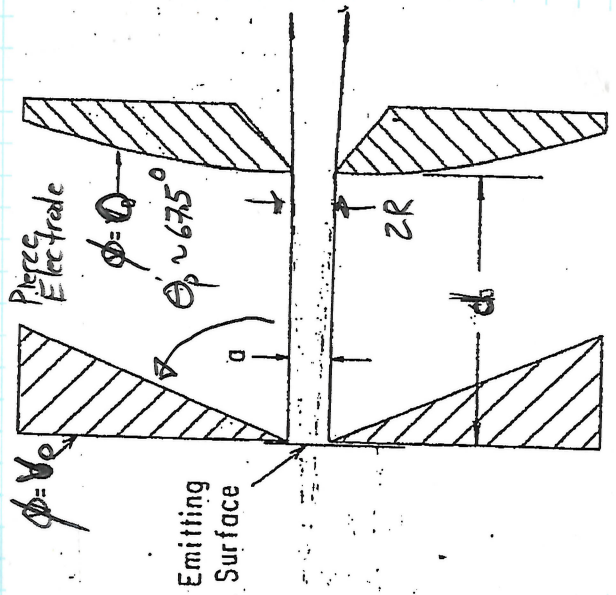
Suppress to avoid destruction of hardware

J. Kwan, LBNL

Practical observation based with real hardware. see A. Chao Accelerator Handbook World Press.

### 2) Optical Aberrations

Nonlinear fields must be suppressed to preserve good beam quality.



Real Beam 3D not 1D.

Find angled "Pierce Electrodes" can be used to keep beam approx 1D. But even with detailed code optimization, find must

Angle helps suppress radial

beam expansion due to space charge for finite radial extent beam.

$$d \gtrsim (3 \text{ to } 4) R$$

$R$  = beam aperture radius.

A.T. Forrest, Wiley, 1988

Note that:

$$\frac{\text{current density}}{J} = \text{const} \frac{V_0^{3/2}}{d^2} \sim$$

$$\left\{ \begin{array}{l} V_0^{-1/2} \sim d^{-1/2} \\ V_0^{-5/2} \sim d^{-5/2} \end{array} \right.$$

$$d \lesssim 1 \text{ cm} \\ d > 1 \text{ cm}$$

$$(V_0 \sim d) \\ (V_0 \sim d^{1/2})$$

Current

$$I = \pi R^2 J \sim R^2 V_0^{3/2} \sim V_0^{3/2}$$

"Child-Langmuir Scaling"

$R \sim d$  to control aberrations.

$J$  decreases as source size increases  
 But  $I$  increases as source size increases

Also, want sources that deliver maximum current in phase-space  
 volume measures of the beam.

Will find later that normalized rms x and y-emittances measure  $\perp$  phase-space  
 areas of the beam;

$$\epsilon_{nx} = (e\beta) \left[ \langle x^2 \rangle \langle x'^2 \rangle - \langle x x' \rangle^2 \right]^{1/2}$$

$$\epsilon_{ny} = (e\beta) \left[ \langle y^2 \rangle \langle y'^2 \rangle - \langle y y' \rangle^2 \right]^{1/2}$$

$\perp$  Phase-Space  $\sim \epsilon_{nx} \epsilon_{ny}$   
 Volume

Beam is not converging or diverging:  
 $\langle x x' \rangle = 0$

For uniform density beam in aperture:

$$R = 2 \langle x^2 \rangle^{1/2}$$

For NR ions born at temperature T:

$$\gamma \approx 1$$

$$\beta^2 \langle x'^2 \rangle = \frac{1}{c^2} \langle v_x^2 \rangle$$

Thus

$$= \gamma \beta [\langle x'^2 \rangle \langle x^2 \rangle - \langle x x' \rangle^2]^{1/2} \approx \beta \langle x'^2 \rangle^{1/2} \langle x^2 \rangle^{1/2} = \frac{R}{2} \left( \frac{k_B T}{m c^2} \right)^{1/2}$$

$$\left[ \text{Phase} \sim \frac{E_x E_y}{\text{Volume}} = \frac{R^2 k_B T}{4 m c^2} \right]$$

Assume x and y plane T equal.

$$\beta \langle x'^2 \rangle^{1/2} = \frac{1}{c} \left( \frac{k_B T}{m} \right)^{1/2}$$

$$\frac{1}{2} m \langle v_x^2 \rangle = \frac{1}{2} k_B T$$

$\frac{1}{2} k_B T$  per DOF

This leads naturally to a measure of source performance called

"Brightness" defined as

$$B \equiv \frac{\text{Transverse Brightness}}{\text{Phase-space Vol.}} = \frac{I}{E_x E_y} = \frac{\pi R^2 J}{\frac{R^2 k_B T}{4 m c^2}} \propto$$

$$B = \frac{16 \pi \epsilon_0 \left( \frac{2q}{m} \right)^{3/2} V_0}{9 d^2 \left( \frac{k_B T}{m c^2} \right)}$$

$$J = \frac{4 \epsilon_0 (2q)^{3/2} V_0}{9 d^2}$$

Note:

- B independent of source radius R
- Want ions as low a temp T as possible and high a voltage  $V_0$  as possible } Hard to do

# Summary: Sources

- Well functioning sources crucial for accelerators:
  - Bright: compact phase-space  $\Leftrightarrow$  compact beam
    - smaller (more economical) structures
    - lower losses to mitigate damage

Improving sources allows running higher intensity to get more out of accelerator.

- Upgrade source  $\Leftrightarrow$  Upgrade accelerator
- Need also high reliability for long periods of time
  - Source not operational, then expensive machine will not work

Sources high leverage, but also difficult:

- Technology and physics strongly coupled
- Rely on difficult material science, plasma physics, etc.

Possible to teach a whole course on just one type of source technology,

Many types of sources. Only scratched surface in this lecture:

<u>Electrons</u>	<u>Ions</u>	<u>Radioactive</u>	<u>Antiparticle</u>
Thermionic emitters	hot plate (low Q)	Capture / cool	Accel. drives source
Field Emission (point)	plasma (higher Q)		- capture, cool, inject
Photocathodes	discharge FCR laser driven e <sup>-</sup> beam driven		

Source projects great for PhDs: rich physics, improvements high leverage